



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application Serial No. 10/046,330
Filing Date 10/25/2001
Inventor W. Yi et al.
Assignee Honeywell International Inc.
Group Art Unit 2818
Examiner Phuc T. Dang
Attorney's Docket No. JM32810-CIP
Title: Physical Vapor Deposition Targets

RESPONSE TO MARCH 5, 2003 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

In the Specification

None.

In the Claims

None.

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